Leica STELLARIS 8 Confocal/FLIM/tauSTED Operating Instructions

System Overview (STED Application)





Hardware/Software Indications for STED Applications

White light laser (WLL) lines for conventional excitation: 440-790 nm.

STED Depletion lines – There are three STED depletion laser lines: 592 nm, 660 nm, and 775 nm.

LED OFF

Keys Always ON





Hardware information





1	White Light Laser (WLL)	6	STED Lines
2	Scan Head	10	External light source
3	Microscope	12	Workstation
4	Monitor(s)	14	External cooling (chiller)
5	Control panel	15	Supply Unit

System Start-up



Turn on the power (wait for few seconds) and laser button as shown in the figure 1.
*Note: Do not touch any key.

2. Turn ON the computer and wait.
 3. Log into the computer with your own KCCI user account.
 4. Record the starting time at the KCCI website



Keys Always ON but to before using the STED application follow the instruction 5.

5. Toggle the Keys (turn OFF and turn ON) –



6. Start the system by double clicking the LAS X icon on the desktop. <u>*Note:</u> The LAS X software is used to control all system functions and acts as the link to the individual hardware components. Image acquisition, image analysis and image processing are carried out using LAS X.



Leica Application Suite X 4.5.0.25531	Leica MICROSYSTEMS
Configuration : Microscope :	machine.xlhw 🗘 DMI8 🗘
STED : Load settings at startup :	
	OK Cancel

7. Select the Machine as configuration and DM18 in the Microscope section as shown.
8. Toggle the Turn OFF button to Turn ON from the panel for STED as well as for the Load Settings at Start-up.
9. Now start LAS X by clicking the OK button.



10. Wait Until the software initialization completes.11. Wait for the LAS X Graphical User Interface window.

Sample mounting and fluorescence observation through eyepieces





- 1. Tilt the illumination column.
- 2. Verify that the correct sample holder stage inset is correctly secured in the XY stage.





3. If using immersion lens, clean the lens and apply proper immersion.

4. Never clean dry lens!

5. If suspected dirty, or if immersion gets onto a dry lens, contact KCCI staff immediately!

Sample mounting and fluorescence observation through eyepieces

6. Secure your sample, thin coverslip Facing Down. The objectives cannot focus through a glass slide. If using immersion lens, quickly bring the immersion to contact with the sample using coarse/fast Z-focus (and XY-stage) adjustment on the "Smart Move" controller.



Coarse/fine XY-stage

7. Using the Aperture (aperture diaphragm) or Field (field diaphragm) keys, the motorized diaphragms can be changed at any time. The display on the Touch Screen changes accordingly.



Coarse/fine /Z-Focus



Using the microscope touchscreen



On touch screen click the highlighted icon for basic microscope settings. Select the status/illumination menu using light source icon. Adjust the field diaphragms using + and – keys. FIM: Fluorescence intensity manager.

FINT: Fluorescence intensity manager.

IL: Incident light (Fluo: Fluorescence light)

TL: Transmitted light

Contrast Tab or Modality Tab:

Transmitted light: Bright field (BF) **Incident light**: Fluorescence (FLUO) **Combination**: Fluorescence-Phase (FLUO-PH) and (CS)

The shutter can be operated using the buttons on the touch screen.

Click the FLUO for fluorescence incident light method

The available filter cubes are displayed. Select the desired cube using the corresponding button.



To see on the screen, use the highlighted settings.





To see through the ocular, use the <u>highlighted settings.</u>



Using the microscope touchscreen

Note: Use the microscope touch screen to select the objective lens not the software



X/Y ZAFC Z Focusdrive Microscope EX Coarse Fine Current Position: ×Z 103 µm Set/Clear

Objective Tab

- 1. Shows the total magnification on the eyepieces.
- 2. Available objectives: Here 5.
- 3. Click the objective button from the touch screen and select the required objective.
- 4. If the selection of the objective start blinking, press it one more time to confirm the selection.

Note. For STED applications 100x/1.4 oil and 86x/1.2W for water are available.

5. Use only <u>Type F immersion liquid</u> for the objective if required.

6. In the objective Tab: Port: Eyepieces 100 % indicates the whether the light is going to the eyepieces or to the camera.





Structure of the LAS X Graphical User Interface



Click the <u>configuration button</u> to activate the configuration



STEP:1 Turning ON the LASER

<u>steq</u> 0		STELLARIS 8 🗘 Configuration Acquire Process Quantify Analysis 🗎	
IPS	Beam Path		
Laser Config			<mark>1</mark>
		Currently available Lasers	
STED	Objective	▼ Adjust Laser Settings	*
	Ø	405 Diode: OFF	
Super-Z	Hardware	WIL: ON 85.00 %	
*		STED 592: ON 100.00 %	
User Config	Memory	STED 660: ON 100.00 %	
Dye Database	CAMServer	STED 775: ONO 100.00 %	

- Turn ON the white light laser (WLL) from the software.
- The STED configuration has three STED depletion laser lines: 592 nm, 660 nm, and 775 nm.
- Toggle the OFF button to turn ON to switch ON the WLL and Required STED Lines from the Laser Configuration sub-panel under the Configuration panel.
- Note: Keep the STED lines power (100 %) as indicated the Left panel.
- Wait for at least 30 minutes to warm up the LASERs.

STEP 2. Beam Alignment

*Note: Beam alignment is the essential condition for the STED applications.



- Click the STED option under the configuration panel.
- Click on Align Beams button and wait for 3-4 minutes to complete the process.
- In case Alignment Fails. Repeat the NOTE 1 and NOTE 2.
- After successfully completing the beam alignment close the dialog box and go to the Acquire panel.

Click the Hardware button to select the Panning, Resolution etc.

Stellaris 8	Configuration Acquire	Process Quantify Analysis 🖯
IPS Beam Path	🗭 Hardware Settings	0
Laser Config	▼ Panning Step Size 3	 Data Transfer Mode Direct Direct Overflow Maximum Integration Time
Objective Super-Z Hardware	 ✓ Resolution Bit Depth Ø ◆ Ø Ø Z-Movement 12 16 	 Online Maximum Projection during Acquisition Online Maximum Projection during Acquisition Image Orientation Flip X
User Config User Config Dye Database	 Activate 2-Movement Emittation Bidirectional XYZT Acquisition Manual Microscope Control Enable during Acquisition of Series Detector Auto Selection 	 LDM/Wizard Stop Behaviour Wait until frame is ready

Click the Objective Icon to select the desired objective the configuration panel. *Note: Use the touch screen to select the desired objective lens

<u>leice</u>	 0	7/	STELLARIS 8 🗘		Configuration		Acquire	>	Process	\rightarrow	Quantify	\geq	Analysis 🗎 🔵
	PS	Beam Path											
Laser	Config	USB Panel	Į (Obje	ctive Con	figu	ration			Selected	 Objective HC P	L APO C52	20x/0.75 IMM
			▼ Objectives										*
	-					ſ	HC PL APO C	52 86x/1	.20 WATER	ľ			
ОЫ	ective	Super-Z					Empty 1x/0	0.00 52 100x/1	140.01				
1	ີ່						HC PL APO C	52 10x/0	.40 DRY				
							HC PL APO C	52 20x/0	0.75 IMM				
Hard	dware						HC PLAPO C	57 40x/1	.30 OII	J			
	0	I, II	 Objective Attrib 	utes						<u> </u>			*
User	Config	Memory	lype		HC PL APO CS2	. Keso	ution XY(488nm)) 26	0.27	Phase R	ing		
User	comig	wentory	Magnification			Reso	ution Z(488nm)	11	107.87	IC Prism	IS	C1;C	
		•	Numerical Aper	ture	0.75	Free	Working Distance	e 66	50	Techniq	ue	CS2;	Waterdispen
4			Immersion		IMM	Focu	5 Depth	U		Conden	ser Prism DIC	K6;K	
			Coverglass			Tocu	s Offset	U		Order N	umber	1150	0343
Dye D	atabase	CAMServer											

To see the overview of the fluorophores, click the Dye Database.



Click the Acquire panel to image the specimen. The Acquire panel is shown in the figure.



STEP 3.

Selection of dye, excitation light (WLL), and STED Line

* The instructions below are for the single-color STED applications



Trans PMT - Off

WLL

(II.)

Shutter Intensity 6.00 ᆃ

ON O

6

STEP 4. Selecting location for STED applications



Selecting Intensity Mode



Selecting Intensity TauGating



Selecting Intensity TauSTED



STEP 5. Selecting Modes for the STED: Intensity, TauGating, and TauSTED

22 — O _____ STELLARIS 8 🗘 Configuration Acquire Process Quantify Analysis 🖯

- Create a **2 more additional duplicate panels** as shown in the left panel.
- Click the detector bar and change the **TauModes** in the corresponding panels as **Intensity**, **TauGating and TauSTED**.
- Note: Don't try to find the FOV using STED beam. Reduce the STED beam intensity to 0.

20

- Tune the STED line intensities from preset 0 value to 30 % in each panel.
- Increase the Line Accumulation to 4.



• Click the Capture button.

Selecting STED Lines Intensities



Loading your imaging method



Image Size :

Pixel Size :

Pixel Dwell Time : 3.16 us

Frame Accu : 🛛 🖾

Pinhole : 🔘

AU 🗘

580

Optical Section :

Line Average : Line Accu :

Frame Average :

Emission λ [nm] :

Pinhole

Click the Acquisition panel under Acquire and click the Live to check the specimen or Capture Image button to record the image.



Shutdown the system



- 1. Save the data and transfer the data to KCCI/data server
- 2. Stop the record time at the KCCI website.
- 3. Turn OFF the white light laser and STED lines from the software.
- 4. Close the software and shutdown the system.
- 5. Wait.
- 6. First turn OFF the Laser button and then Power button.

*Note: Remember, do not touch the key.

Troubleshooting Microscope for STED Application (NOTE: 1) STED lines Turning ON





STED 660 laser need to be turned automatically to ensure guaranteed laser lifetime. The procedure will take approximately 45 minutes.

STED mode will not be accessible during that time. Confocal functionality can be used as usual.

Start SHG tuning now?

Troubleshooting: Click Yes button available on the appeared dialog box and wait till the procedure ends.

Turn OFF the WLL and STED lines from the Laser Overview panel and exit the software.

Troubleshooting Microscope for STED Application (NOTE: 2) Beam Alignment



